

Editorial



It is a great honor to assume the role of Editor-in-Chief of *Sensors and Materials*.

Since its first issue in 1988, published thanks to the efforts of Professors A. Kawabata, K. Takahashi, and K. Toda in collaboration with MYU Scientific Publishing, the journal has served as a vital platform connecting sensor technology and device materials, bridging academia and industry. I sincerely thank all former Editors-in-Chief, reviewers, authors, and readers who have supported the journal's growth. In particular, I acknowledge the outstanding contributions of the previous Editors-in-Chief, Professors T. Nakamura and S.

Sugiyama, and thank Professor M. Ishida, a former Editor-in-Chief, for recommending me for this position. I also pay tribute to Professor K. Toko, a pioneer in taste and olfactory sensors, and Professor K. Maenaka, a leading figure in MEMS sensors who sadly passed away last year. I am committed to honoring their legacy while guiding the journal toward continued development and global impact.

Today, sensor technology plays an indispensable role in automobiles, communications, robotics, biotechnology, medical and healthcare, environmental monitoring, and safety. At the same time, innovations in materials science, including nanomaterials, composites, and biomaterials, are supporting the development of sensor technology. In this context, *Sensors and Materials* must strengthen its role as a trusted platform for disseminating cutting-edge research promptly and fairly, enabling global knowledge exchange.

In the future, we will focus on promoting international submissions, improving transparency and efficiency in peer review, and enhancing the quality of published papers. We will also advance open access initiatives and leverage digital technologies to deliver valuable academic content. Furthermore, we aim to foster interdisciplinary collaboration and industry-academia partnerships so that research published in *Sensors and Materials* can contribute to solving societal challenges.

I am confident that, with the support of Editor Professor J. Wilde, Associate Editors Professors J. Ohta, D. Dao, and K. Sawada, and our dedicated Editorial Board of approximately 50 members, we will achieve these goals. Their expertise and commitment are crucial to the journal's continued success.

Finally, I invite authors to submit papers on their high-quality research and reviewers to continue their invaluable contributions. Together, we will ensure that *Sensors and Materials* continues to strengthen its reputation and expand its impact within the global research community.

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